



U.S. Patent App. No. 09/647,659  
Docket: 033082.052

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

First Named Inventor: DELLER

Application No.: 09/647,659

Filing Date: 10/04/2000

Examiner: GRAYBILL, DAVID E

Group Art Unit: 2814

For: ALIGNMENT PROCESSING MECHANISM AND SEMICONDUCTOR  
PROCESSING UNIT WITH ALIGNMENT PROCESSING MECHANISM

**RESPONSE TO FINAL OFFICE ACTION**

Box AF  
Commissioner for Patents  
Washington, D.C. 20231

A response to the final Office Action mailed May 21, 2002 is being timely filed by the August 21, 2002 due date. The application is to be amended as follows.

**AMENDMENT TO THE CLAIMS**

Claim 17 is to be amended as shown in the enclosed marked up version.

Applicants have also enclosed a clean version of this claim for the Examiner's review.

Applicants submit that the amendment should be entered because it complies with a requirement pertaining to the form of the claim as set forth in the previous Office Action (i.e. the 112 rejection).

No additional fees are due as a result of this amendment.

RECEIVED  
CHIEF SERIALIZED SECTION  
AUG 25 2002  
U.S. PATENT AND TRADEMARK OFFICE